



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Group Art Unit: 1756  
Examiner: Kathleen Duda

1756  
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**OCT 01 2003**  
**TC 1700**

In Re PATENT APPLICATION OF:

Applicant : Minoru WATANABE )

Appln. No. : 10/025,783 )

Filed : December 26, 2001 )

For : METHOD AND APPARATUS FOR )  
FORMING RESIST PATTERN )

Attorney Ref. : MAE 223 C1 )

**SUPPLEMENTAL**  
**AMENDMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

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**TC 1700**

Sir:

In response to Paper 13, dated September 10, 2003, the Applicant is submitting this Supplemental Amendment to correct the Amendment submitted on July 11, 2003, so that the Amendment properly reflects amendments to the claims made by the Examiner in the Notice of Allowance dated April 14, 2003. According to this Supplemental Amendment, please amend the above-referenced application as follows:

**IN THE CLAIMS**

Please cancel claims 8-9, 12, 21-22 and 25 without prejudice or disclaimer to the subject matter recited therein. Please amend claims 1, 10-11, 13, 17, 23-24, 26 and 31-32, and add new claims 33-40, as shown in the listing of claims beginning on the next page under the heading **Amendments to the Claims**.

FEE ENCLOSED: \$  
Please charge any further  
fee to our Deposit Account  
No. 18-0602